Abdul Faheem Khan

List of Publications by Year in descending order

Source: https://exaly.com/author-pdf/6583313/publications.pdf

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25 511 10 22 g-index

25 citations 25 25 713

times ranked

citing authors

docs citations

all docs

#	Article	IF	CITATIONS
1	Intrinsic Properties and Future Perspective of HfO2/V2O5/HfO2 Multi-Layer Thin Films via E-Beam Evaporation as a Transparent Heat Mirror. Coatings, 2022, 12, 448.	2.6	10
2	Nanostructured multi-layer MgF2/ITO coatings prepared via e-beam evaporation for efficient electromagnetic interference shielding performance. Applied Surface Science, 2022, 596, 153584.	6.1	11
3	Synthesis and Characterization of Nanostructured Multi-Layer Cr/SnO2/NiO/Cr Coatings Prepared via E-Beam Evaporation Technique for Metal-Insulator-Insulator-Metal Diodes. Materials, 2022, 15, 3906.	2.9	3
4	Intrinsic Properties of Multi-Layer TiO2/V2O5/TiO2 Coatings Prepared via E-Beam Evaporation. Materials, 2022, 15, 3933.	2.9	6
5	Synthesis and characterization of nanostructured Ge/GeO2 films using spin coating technique. Physica Scripta, $2021, 96, 115803$.	2.5	1
6	Growth and Investigation of Annealing Effects on Ternary Cd1 \hat{a} 'xMgxO Nanocomposit Thin Films. Materials, 2021, 14, 4538.	2.9	4
7	Multi-layer MgF2/ITO coatings for electromagnetic interference shielding. Materials Chemistry and Physics, 2021, 272, 125009.	4.0	4
8	Effect of gold nanoparticles on transmittance and conductance of graphene oxide thin films and efficiency of perovskite solar cells. Applied Nanoscience (Switzerland), 2020, 10, 485-497.	3.1	20
9	ZnO-Ge MULTILAYER THIN FILM STRUCTURES DEPOSITED BY THERMAL EVAPORATION TECHNIQUE. Surface Review and Letters, 2020, 27, 1950149.	1.1	O
10	EFFECT OF OXIDATION TIME ON STRUCTURAL AND OPTICAL PROPERTIES OF ZNO FILMS PREPARED BY HYDROTHERMAL OXIDATION OF ELECTRODEPOSITED ZN COATING ON ITO SUBSTRATE. Surface Review and Letters, 2020, 27, 1950227.	1.1	1
11	GAMMA IRRADIATION-INDUCED CHEMICAL DECOMPOSITION-RELATED BANDGAP ENGINEERING IN SnO2 NANOPARTICLES. Surface Review and Letters, 2019, 26, 1850228.	1.1	2
12	STUDY OF Co/Sn MULTILAYER SYSTEM WITH VARIOUS TIN LAYER THICKNESS AND REFLOW TEMPERATURES. Surface Review and Letters, 2019, 26, 1850153.	1.1	0
13	Nanostructured SnO2 -Ge Multi-layer thin Films with Quantum Confinement Effects for Solar Cell. Recent Patents on Nanotechnology, 2016, 10, 77-82.	1.3	O
14	Electrodeposited Ge Nanostructures Prepared by Different Non-Aqueous Solutions and their Application in Lithium Ion Battery: A Review. Recent Patents on Nanotechnology, 2016, 10, 26-43.	1.3	7
15	Investigation of the mechanical properties of electrodeposited nickel and magnetron sputtered chromium nitride coatings deposited on mild steel substrate. Journal of Adhesion Science and Technology, 2016, 30, 2224-2235.	2.6	8
16	Structural and mechanical properties of (Cr, Ni) N single and gradient layer coatings deposited on mild steel by magnetron sputtering. Tribology - Materials, Surfaces and Interfaces, 2016, 10, 117-125.	1.4	4
17	Structural and optoelectronic properties of nanostructured TiO2 thin films with annealing. Materials Science in Semiconductor Processing, 2015, 29, 161-169.	4.0	44
18	Multilayer Si/Ge thin films with quantum confinement effects for photovoltaic applications. Applied Surface Science, 2014, 296, 185-188.	6.1	14

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19	Structural and optical studies of nanostructured TiO2–Ge multi-layer thin films. Thin Solid Films, 2013, 536, 220-228.	1.8	21
20	Effect of annealing on structural, optical and electrical properties of nanostructured Ge thin films. Applied Surface Science, 2010, 256, 2031-2037.	6.1	43
21	Nanostructured multilayer TiO2–Ge films with quantum confinement effects for photovoltaic applications. Journal of Colloid and Interface Science, 2010, 343, 271-280.	9.4	32
22	Characteristics of electron beam evaporated nanocrystalline SnO2 thin films annealed in air. Applied Surface Science, 2010, 256, 2252-2258.	6.1	120
23	Effect of annealing on electrical resistivity of rf-magnetron sputtered nanostructured SnO2 thin films. Applied Surface Science, 2009, 255, 8562-8565.	6.1	85
24	Optical Characterization of rf-Magnetron Sputtered Nanostructured SnO 2 Thin Films. Chinese Physics Letters, 2009, 26, 077803.	3.3	24
25	Characterization of rf-sputtered indium tin oxide thin films. Materials Chemistry and Physics, 2004, 84, 126-130.	4.0	47